Search Notes

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	131	(438/463).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/26 16:23
L2	1044	(438/455).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/26 16:23
L3	711	(438/458).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/26 16:24
L4	0	("RAYSSAC-OLIVIER.in.").PN.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/26 16:25
L5	54	RAYSSAC-OLIVIER.in.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/26 16:25
L6	16	RAYSSAC-OLIVIER.in. and rough$4	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/26 16:25
L7	7	RAYSSAC-OLIVIER.in. and rough$4 and ion	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/26 16:25
S1	8177	rough$4 and ion with plasma	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/16 23:46
S2	4726	surface with rough$4 and ion with plasma	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/16 23:56

S3	66	surface with rough$4 and ion with cluster with plasma	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/16 23:56
S4	1	surface with rough$4 and ion with cluster with plasma and detachable with substrate	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/16 23:57
S5	1	surface with rough$4 and ion with cluster with plasma and detachable	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/16 23:57
S6	44	surface with rough$4 and ion with plasma and detachable with substrate	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/03 01:19
S7	4	surface with rough$4 and argon with ion same plasma and detachable with substrate	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/17 00:02
S8	1	surface with rough$4 and nitrogen with ion same plasma and detachable with substrate	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/16 23:58
S9	107	(438/463).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/26 16:23
S10	911	(438/455).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/26 16:23
S11	606	(438/458).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/26 16:23
S12	24	surface with rough$4 and ion with plasma and detachable with substrate and etch$3	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/17 00:00

S13	4	surface with rough$4 and argon with ion same plasma and detachable with substrate and etch$3	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/20 15:55
S14	343	surface with rough$4 and argon with ion same plasma and etch$3	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/20 15:55
S15	46	surface with rough$4 same argon with ion same plasma and etch$3	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/20 22:48
S16	11	surface with rough$4 with argon with ion same plasma and etch$3	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/20 15:58
S17	7	surface with rough$4 with argon with ion same plasma and bond$3	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/20 16:04
S18	1	surface with rough$4 with argon with ion adj beam and bond$3	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/03 01:19
S19	13	"6180496"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/20 22:42
S20	5	2002/0014407 2002/0139772	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/20 22:44
S21	4	2002/0014407	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/20 22:43
S22	71	"0014407"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/20 22:44

S23	1	2002/0139772	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/20 22:44
S24	1	"20020139772".PN.	US-PGPUB	OR	ON	2005/03/20 22:45
S25	1	"20020014407".PN.	US-PGPUB	OR	ON	2005/03/20 22:47
S26	0	surface with rough$4 same argon with ion same plasma and etch$3 and gcib	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/20 22:48
S27	0	surface with rough$4 same argon with ion same plasma and gcib	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/20 22:49
S28	8	surface with rough$4 same argon and gcib	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/20 22:49
S29	1	"5849093".PN.	USPAT; USOCR	OR	ON	2005/03/20 22:49
S30	6	(("5,869,354") or ("6,153,495") or ("6,190,778")).PN.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/03/20 23:14
S31	81	rough$4 and surface same smooth and detachable with substrate and smooth	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/20 23:15
S32	1	rough$4 and surface same smooth and detachable with substrate and smooth and ion adj cluster	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/20 23:15
S33	1	rough$4 and surface same smooth and detachable with substrate and smooth and ion with cluster	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/20 23:16
S34	0	rough$4 and surface same smooth and detachable with substrate and smooth and gcib	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/20 23:16

S35	0	rough$4 and surface same smooth and detachable and gcib	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/20 23:16
S36	0	rough$4 and surface and detachable and gcib	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/20 23:16
S37	.0	detachable and gcib	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/20 23:16
S38	40	rough$4 and surface and gcib	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/20 23:17
S39	28	rough$4 and surface same smooth and gcib	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/03 01:19
S40	3312	molecular adj bond$3	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/20 23:17
S41	1	S39 and S40	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/20 23:17
S42	13	rough$4 adj surface same smooth and gcib	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/03 01:19
S43	1	S40 and gcib	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/20 23:20
S44	7	"sf.sub.6" and gcib	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/03 01:19

S45	1	"sf.sub.6" and gcib and bond$3	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/20 23:34
S46	128	(438/463).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/03 01:19
S47	1028	(438/455).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/03 01:19
S48	699	(438/458).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/10/03 01:19
S49	46	surface with rough$4 and ion with plasma and detachable with substrate	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/03 01:19
S50	1	surface with rough$4 with argon with ion adj beam and bond$3	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/03 01:19
S51	10	"sf.sub.6" and gcib	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/03 01:19
S52	15	rough$4 adj surface same smooth and gcib	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/03 01:19
S53	31	rough$4 and surface same smooth and gcib	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/10/03 01:19